# Monthly LabAdviser update: 14/5 2018

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| Updated Subject | Contributor | Link to the updated pages |
| **KOH**  The page for KOH etching has been reorganized and how to calculate the concentration when mixing KOH from either a premade solution or KOH pills has been added. | **Karen Birkelund @danchip** | [KOH\_Etch](http://labadviser.danchip.dtu.dk/index.php/Specific_Process_Knowledge/Etch/KOH_Etch)  [KOH\_Etch/ProcessInfo](http://labadviser.danchip.dtu.dk/index.php/Specific_Process_Knowledge/Etch/KOH_Etch/ProcessInfo) |
| **ALD-HfO2**  Results for deposition of HfO2 in ALD1 | **Pernille V. Larsen @danchip** | [Thin\_film\_deposition/Deposition\_of\_Hafnium\_Oxide](http://labadviser.danchip.dtu.dk/index.php/Specific_Process_Knowledge/Thin_film_deposition/Deposition_of_Hafnium_Oxide)  [/Thin\_film\_deposition/ALD\_Picosun\_R200/HfO2\_deposition\_using\_ALD](http://labadviser.danchip.dtu.dk/index.php/Specific_Process_Knowledge/Thin_film_deposition/ALD_Picosun_R200/HfO2_deposition_using_ALD) |

# Equipment Manuals updated in LabManager:

As an approved user on a piece of equipment you have to make sure you have read and understood the latest version of the manual before using the equipment.

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|  | **Manual for DRIE-Pegasus** |
|  | **Manual for SEM Supra 2** |
|  | **Manual for III-V ICP** |
|  | **Manual for AOE** |
|  | **Manual for ICP Metal Etch** |
|  | **Manual for ellipsometer VASE** |
|  | **Manual for ASE** |
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|  | **APV and manual for fume hoods in the cleanroom** |
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